

DATE E-FILED: March 7, 2007

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Jeanne E. Haubrich et al.

Application Serial No.: 10/666, 912

Filed: September 19, 2003

For: PROCESS FOR FORMING A
PATTERNED THIN FILM
STRUCTURE ON A SUBSTRATE

Group Art Unit: 1734

Examiner: Chan, Sing P

Confirmation No. 6475

Attorney's Docket No:
07783.0054.CPUS02

RESPONSE TO OFFICE ACTION

MAIL STOP AMENDMENT

Commissions for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Dear Sir:

This is in response to the Office Action dated December 14, 2006, and is submitted on or before the due date of **March 14, 2006**. The Examiner is requested to enter the amendments and reconsider the application.

The U.S. Patent and Trademark Office is hereby authorized to charge any fee deficiency, including fees under §1.17; or credit any overpayment, to our Deposit Account No. 08-3038 referencing Atty. Dkt. No. 07783.0054.CPUS02.